THEORETICAL STUDY OF THE EFFECTS OF DISLOCATIONS IN MONOLITHIC III-V LASERS ON SILICON

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Abstract—In this work, we present an approach to modelling III-V lasers on silicon based on a travelling-wave rate equation model with sub-micrometer resolution. By allowing spatially resolved inclusion of individual dislocations along the laser cavity, our simulation results offer new insights into the physical mechanisms behind the characteristics of 980 nm In(Ga)As/GaAs quantum well (QW) and 1.3 μm quantum dot (QD) lasers grown on silicon. By studying the reduction of the local gain in carrier-depleted regions around dislocation locations and the resulting impact on threshold current increase and slope efficiency at high dislocation densities, we identify two effects with particular importance for practical applications. First, a large minority carrier diffusion length is a key parameter inhibiting laser operation by enabling carrier migration into dislocations over larger areas, and secondly, increased gain in dislocation-free regions compensating for gain dips around dislocations may contribute to gain compression effects observed in directly modulated silicon-based QD lasers. We believe that this work is an important contribution in creating a better understanding of the processes limiting the capabilities of III-V lasers on silicon in order to explore suitable materials and designs for monolithic light sources for silicon photonics.

Index Terms—Quantum dot lasers, quantum well lasers, semiconductor device modeling, silicon photonics

I. INTRODUCTION

Dislocation-Induced performance degradation with respect to luminescence efficiency and reliability has been a major concern for semiconductor researchers ever since the early days of semiconductor injection lasers in the 1970s [1]-[3]. Modern epitaxial growth techniques have matured to a level that large-area lattice-matched multi-layer wafers with dislocation densities smaller than 10⁴ cm⁻² can be produced [4], meaning that statistically nine out of ten 2×500 μm² lasers have an entirely dislocation-free active region. As a consequence, the focus of the latest research has shifted towards realizing more challenging structures, with the epitaxial growth of III-Vs on silicon gaining particular attention due to the prospect of merging high optical gain materials with silicon photonics. The high density of threading dislocations emerging from the active region remains, however, the main factor limiting the progress of incorporating III-V-on-Si gain blocks in monolithically integrated silicon photonic optoelectronic circuits. Despite considerable advances in crystal growth technology and the optimization of defect filter and buffer layers, quantum well (QW) lasers on silicon have failed to work reliably [5]-[8]. Instead, InAs/GaAs quantum dots (QDs) have established themselves as the gain medium of choice for mismatched growth due to their higher tolerance to dislocations, since ultrafast carrier capture into QDs reduces the effective diffusion length and prevents the majority of injected carriers from migrating into defects [9]-[11].

To date, the performance differences seen for QD and QW lasers grown on silicon remain relatively unexplored. In our previous work, we have shown travelling-wave rate equation simulations using a macroscopically averaged carrier loss time inferred from a dislocation-limited diffusion length in order to explain the performance discrepancies between GaAs-based QW and QD lasers grown on silicon [9]. While this model was capable of reproducing experimentally observed performance trends, it allowed only limited access to the underlying physical processes. Here, we introduce therefore an approach to simulating such devices by using a rate equation travelling-wave model with sub-micrometer spatial resolution, which enables the inclusion of individual dislocations in the laser cavity. The objective of this work is to identify the main mechanisms responsible for the drop in performance typically observed at dislocation densities ≥10⁴ cm⁻², with a special focus on the limitations QW structures experience. Our high-resolution approach points out the role diffusion plays in the functionality of QW and QD devices and gives new insights into the local phenomena arising from the interplay of gain, the carrier density, and the photon density in the presence of dislocations.

II. EXPERIMENTAL PERFORMANCE TRENDS

The performance dependence of III-V lasers grown on silicon on dislocation density offers a route to understanding the fundamental implications dislocations have each for QD and QW devices. Fig. 1 suggests that there is a correlation between...
high threshold current densities and high dislocation densities in monolithic QD lasers on silicon. This is consistent with the perception that dislocations act as nonradiative defect centers [1], [3], [12], [13], which result in higher laser thresholds through increased carrier loss [14]. More data points at low dislocation densities would be necessary though to pinpoint a trend with greater confidence. Whereas good lasing characteristic have been obtained even for dislocation densities as high as $3 \times 10^6$ cm$^{-2}$ [15], monolithic GaAs-based QW lasers on silicon have only been reported in the comparably small dislocation range of $2 \times 10^5$ cm$^{-2}$ to $10^7$ cm$^{-2}$ [8], [20]-[23]. Together with the lack of systematic studies comparing similar devices at varying dislocation densities, this makes these data insufficient for the identification of reliable performance trends. Bearing in mind that QD lasers in general can intrinsically have lower threshold currents due to their reduced active region volume, the many publications reporting QW laser threshold current densities of several kA/cm$^2$ [21], [23]-[25], as opposed to the few published sub-kA/cm$^2$ thresholds [23], [26]-[28], suggest nevertheless that QW lasers are more susceptible to dislocation-induced threshold current increase.

Although the literature is much less clear with respect to a possible light-current ($LI$) slope dependence due to the influence of the laser cavity and active region design, the authors of [29] and [30] report a distinct slope efficiency drop with rising dislocation number. In [30] it is suggested that the slope reduction may be a consequence of increased optical scattering loss at dislocation cores or of a reduced internal quantum efficiency. Based on the available data in the literature, there is no clear indication as to what extent the same applies to QW lasers.

III. NUMERICAL MODEL

A standard multi-level rate equation travelling-wave model is used to simulate narrow-ridge waveguide QD and QW lasers grown on silicon substrate [31]-[34]. The carrier equations (1) and (2) for computation of the QW carrier numbers comprise two levels representing the QWs themselves and the barrier layers (BLs) including current injection, carrier capture, relaxation, and re-emission, nonradiative recombination and dislocation-induced carrier loss, as well as a lateral diffusion term and lasing. It should be noted that $\tau_{\text{dis}}$ is a vector inducing carrier loss at predefined dislocation positions only rather than being an effective laser parameter, as further explained in Section III. An overview of all used variables and parameters can be found in Table I.

\[
\frac{dN_{\text{BL}}}{dt} = \frac{\eta}{e} \frac{\Delta V_{\text{BL}}}{L} - \frac{N_{\text{BL}}}{\tau_{\text{cap}}} - \frac{N_{\text{QW}}}{\tau_{\text{esc}}} - \frac{N_{\text{QW}}}{\tau_{\text{nr}}} - \frac{N_{\text{BL}}}{\tau_{\text{diff}}} - \frac{N_{\text{BL}}}{\tau_{\text{dis}}} - \frac{\Delta N_{\text{BL}}}{\tau_{\text{diff}}} - V_{\text{gr}} \mathcal{G}_{\text{QW}} S \frac{\Delta \tau_{\text{QW}}}{\tau_{\text{QW}}} \frac{\Delta V_{\text{QW}}}{L}
\]

(1)

\[
\frac{dN_{\text{QW}}}{dt} = N_{\text{BL}} - \frac{N_{\text{QW}}}{\tau_{\text{cap}}} - \frac{N_{\text{QW}}}{\tau_{\text{nr}}} - \frac{N_{\text{QW}}}{\tau_{\text{dis}}} - \frac{\Delta N_{\text{QW}}}{\tau_{\text{diff}}} - V_{\text{gr}} \mathcal{G}_{\text{QW}} S \frac{\Delta \tau_{\text{QW}}}{\tau_{\text{QW}}} \frac{\Delta V_{\text{QW}}}{L}
\]

(2)

The QD carrier rate equations contain two additional levels representing the QD ground and the first excited state. The main distinction of (4) – (6) is the inclusion of the QD occupation factors $f_{\text{QD},\text{ES}} = (1 - f_{\text{ES},\text{ES}})$ in the QD levels, and the fact that carrier migration is only possible in the BL and wetting layer (WL) due to the in-plane carrier confinement given by the spatially isolated QDs [11]. For our purposes, an excitonic approach is deemed sufficient, since electrons have a higher likelihood of interacting with dislocations due to their higher mobility compared with holes. Migration of electrons into dislocations is, therefore, expected to pose the limiting factor.
for the performance of bipolar devices on silicon [35].

$$\frac{dN_{BL}}{dt} = \frac{\eta I}{eL} - \frac{N_{BL}}{\tau_{cap}} + \frac{N_{WL}}{\tau_{esc}} + \frac{N_{ES}}{\tau_{relax}} - \frac{N_{BL}}{\tau_{dis}} \frac{\Delta N_{BL}}{\tau_{diff}}$$  \hspace{1cm} (3)

$$\frac{dN_{WL}}{dt} = \frac{N_{BL}}{\tau_{cap}} + \frac{N_{WL}}{\tau_{esc}} + \frac{N_{WL}}{\tau_{nr}} - \frac{N_{BL}}{\tau_{dis}} \frac{\Delta N_{WL}}{\tau_{diff}}$$  \hspace{1cm} (4)

$$\frac{dN_{ES}}{dt} = \frac{N_{WL}^f}{\tau_{diff}} + \frac{N_{ES}}{\tau_{relax}} - \frac{N_{ES}}{\tau_{nr}} - N_{ES} \frac{\Delta E_{ES}}{\tau_{diff}}$$  \hspace{1cm} (5)

$$\frac{dN_{GS}}{dt} = \frac{N_{GS}}{\tau_{diff}} - \frac{N_{GS}}{\tau_{relax}} - \frac{N_{GS} G_{QD}}{L} \frac{\Delta E_{QD}}{\tau_{diff}}$$  \hspace{1cm} (6)

The electronic properties given by the carrier equations couple with the laser’s optical behavior via the QW and QD gain functions (7) and (8) and the photon density $S$, which is computed based on the forward and reverse travelling-wave electric field $E^\pm$ equations (9). A digital gain filter is applied to (9) in order to shape the gain spectrum acting on the optical fields [36]. The QW model is set up for emission at 980 nm, while the QD model lases at 1.3 $\mu$m. The different emission wavelengths reflect practical device epistuctures and do not affect the simulation results shown in the following figures.

$$g_{QW} = g_0 \ln\left(\frac{N_{QW}}{N_{tr}}\right)/(1 + \varepsilon S)$$  \hspace{1cm} (7)

$$g_{QD} = g_{max}^Q f_{fr} + f_{fr}^Q - 1)/(1 + \varepsilon S)$$  \hspace{1cm} (8)

$$\left(\frac{1}{v_{gr}} + \frac{1}{v_{dr}}\right) E^\pm(z, t) = \left(\frac{\tau_{gr}}{v_{gr}} - \frac{\tau_{dr}}{v_{dr}} - i\delta\right) E^\pm(z, t) + \frac{i\delta}{v_{dr}} E^\pm(z, t)$$  \hspace{1cm} (9)

Many travelling-wave models are suitable for relatively large space steps $\Delta z$ of around 10 $\mu$m, since the maximum possible $\Delta z$ is dictated by the smallest deployed time constants via $\Delta z = \tau_{dr}/\Delta I$. Although large $\Delta z$ are advantageous in terms of simulation time, they only allow the use of averaged, effective laser parameters, for instance an overall reduced nonradiative recombination time to account for an increased number of dislocations in the active region, which are not entirely able to describe the physics of III-V lasers on silicon accurately. In these simulations, $\Delta z$ is, therefore, reduced to the sub-micrometer level, where a step size of 500 nm offers a good trade-off between physical accuracy and computational feasibility. The Courant Friedrichs Lewy condition is equal to 1, ensuring numerical stability [37].

IV. IMPLEMENTATION OF DISLOCATIONS

In order to study the effects of threading dislocations in GaAs-based laser active regions, nonradiative recombination centers are placed on a regular grid along the laser cavity, modelled as laser sections of ultrafast carrier loss at rate $\tau_{dis}^{-1}$ in order to represent fast carrier capture into defect states. Since the exact dislocation carrier capture time is not known, we assume here a capture time of the order of a few picoseconds, comparable with the one into QD states [38], [39]. In reality, the physical radius of an actual dislocation core is $\mu$m offers a good case scenario in terms of laser performance [42], as the number of carriers affected by diffusion-assisted carrier loss is maximized. A
realistic III-V laser grown on silicon has a random dislocation distribution allowing for variations in the laser performance, where slightly better than average performance is obtained from devices with large dislocation-free regions. Lastly, dislocation-induced carrier loss is ignored in the QD levels due to the negligible number of threading dislocations compared with the number of QDs per active layers.

V. KEY FINDINGS AND DISCUSSION

Fig. 2(a) shows an example of the QW carrier density distribution at twice the laser threshold obtained for a dislocation density \( \rho_{\text{dis}} \) of \( 1 \times 10^6 \) cm\(^{-2} \), equating to ten dislocations in a 2×500 \( \mu \)m laser, as well as the carrier density distribution at the same output power level in the absence of dislocations. It can clearly be seen that the influence of carrier loss at the only 500 \( \mu \)m-long dislocation positions is intensified by carrier diffusion, which causes the carrier density over several micrometers to fall below the threshold value. The large minority carrier diffusion length in GaAs-based III-V materials, set to 10 \( \mu \)m in these simulations, contributes therefore to an increased sensitivity to defects [35]. The carrier density in dislocation-free regions must, therefore, be increased in order to attain the required cavity threshold gain. The QD carrier profile depicted in Fig. 2(b), on the other hand, illustrates that ultrafast carrier capture into the dot states prevents strong dips in the ground state carrier density. As a consequence, the ground state carrier occupation in the vicinity of dislocations drops by only about 10\%, despite the BL and WL carrier densities dropping to about 70\% of their dislocation-free threshold level (Fig. 2(c)). The QD excited state carrier density is similarly reduced, but only since captured carriers relax directly into the ground state.

The behaviors shown in Figs. 2(a) and (b) are reflected in the local gain profiles as depicted in Figs. 3(a) and (b). Fig. 3(a) reveals that carrier-depleted areas around dislocations in the QWs are highly absorptive due to the logarithmic nature of the QW gain function. It is only at higher current injection levels that defect states become populated, as indicated in dark grey, so that diffusion-assisted carrier loss becomes less severe [43].

Fig. 3. Insets of the (a) QW and (b) QD gain profile around a dislocation in comparison with the gain profile without dislocations at the same power level (dotted line). The effect of the 10 \( \mu \)m-long diffusion length can clearly be seen. Fig. 3(a) illustrates the saturation of defect states with rising injection level (~2I\(_{\text{th}}\) in light grey, ~4I\(_{\text{th}}\) at dark grey). The gain dips in Fig. 3(b) result from locally reduced BL and WL carrier densities, as shown in Fig. 2(c). Note the different y axis scales for the QD and QW gain.

The QD modal gain, in contrast, exhibits only a minor dip in the vicinity of a dislocation, as the high ground state occupation due to fast carrier capture helps to ensure overall high gain. It is interesting to note that the threshold gain in individual regions moves closer to the maximum ground state gain of 25 cm\(^{-1} \) (after (8), assuming maximum electron and hole ground state occupation probabilities of 1 and 0.5, respectively), as this increases gain compression effects [45]. This is potentially a smaller issue for high-gain QD lasers as modelled here, but might pose a problem for QD lasers at high dislocation densities with limited modal gain (10 cm\(^{-1} \) – 20 cm\(^{-1} \), for example). Besides high damping induced by a short differential carrier lifetime, this offers another possible explanation of the large K-factors so far observed in directly modulated QD lasers grown on silicon [46], [47].

Figs. 4(a) and (b) show results of simulated QD and QW \( LI \) curves for device dimensions of 2×500 \( \mu \)m\(^{2} \) at different \( \rho_{\text{dis}} \) confirming the experimentally observed trends of increased

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Fig. 4. Simulated \( LI \) curves of an HR-coated/as-cleaved 2×500 \( \mu \)m\(^{2} \) (a) QD and (b) QW laser for various dislocation densities \( \rho_{\text{dis}} \) using the parameters shown in Table I. (c) Inset of the forward propagating photon density in a QW laser versus the longitudinal position for two different diffusion lengths.
threshold currents and, in the case of QD devices, a reduced slope efficiency [29], [30]. The carrier lifetime reduction is a well-known origin of a linearly shifted $LI$ curve towards higher currents [14], yet from the direct comparison of Figs. 4(a) and (b) it becomes obvious that the modelled QW laser suffers from a much larger threshold current increase than its QD counterpart. The key reason for this is the detrimental impact of lateral carrier diffusion, which allows diffusion-assisted BL and QW carrier loss within a radius of several micrometers around a dislocation. The influence of carrier diffusion in QD active regions, in contrast, is naturally much reduced due to rapid carrier capture into QDs, where the carriers are laterally confined and remain isolated from nearby dislocations [11]. For this reason, QD lasers require a much higher dislocation density than QWs to reduce the overall carrier density to a critical level where it limits QD carrier capture and begins to increase the laser threshold more significantly. It should be clarified that the absolute threshold current increase with dislocation density depends on the initial laser threshold without dislocation. Since many practical QW devices would have shorter cavities, which allow lower thresholds, slightly better performance than shown in Fig. 4(b) would be achieved for a 200 μm long QW device, for example. The trend of with dislocation density rapidly increasing threshold currents, however, remains unchanged.

The second typical feature, the $LI$ slope reduction, is a result of two mechanisms. The first one is the reduction in local gain around dislocations, since the photon density building up while propagating along the laser cavity experiences a slight drop in these regions, as illustrated in Fig. 4(c). Hence, it can be understood intuitively that photons travelling along a laser cavity with many dislocations experience less amplification than photons in the presence of only a few dislocation-induced absorptive regions. While the absorption strength of dislocations is much more pronounced in QW lasers, as is evident from the comparison of Figs. 3(a) and (b), it should be noted that QD lasers, with their smaller modal gain, will be less able than QWs to compensate for locally reduced gain. Practically, in QW lasers this effect is overshadowed by the rapid threshold current increase, as illustrated in Fig. 5(a).

The second contribution to the slope efficiency reduction is effectively a reduced current injection efficiency due to excess dislocation-induced carrier loss in the continuum states. As shown in Fig. 5(b), the QD $LI$ slope begins to decrease substantially from $\rho_{loc} \geq 10^7$ cm$^{-2}$, where the BL and WL carrier densities have started to decrease to a level where sufficient carrier capture into the QDs becomes problematic. This effect is more dominant in QD lasers, which allow lasing at higher dislocation densities in the first place. A similar trend was observed in our results published in [9], yet the simulation of dislocations based solely on a macroscopically averaged carrier loss time constant led to a smaller slope decrease than observed here and in [29], for example. We believe, therefore, that the reduction in local gain as a consequence of localized nonradiative recombination could be an integral element in understanding the performance of III-V lasers grown on silicon.

The hypothesis that diffusion-assisted carrier loss in originally defect-free regions is a major problem for QW lasers at elevated dislocation densities, even in the theoretical absence of dislocation climb, can be confirmed by modelling QW structures at different diffusion lengths. As shown in Fig. 5(a), the QW threshold current increase with dislocation density is substantially reduced for smaller diffusion lengths of $L_{diff}^{QW} = 5$ μm and $L_{diff}^{QW} = 1$ μm, similar to the behavior of the QD laser, because fewer carriers are affected by dislocation-induced carrier loss. This observation is in agreement with the performance demonstrated by GaN optical devices, for example, where the short minority carrier diffusion length is believed to play a key role in enabling high light emission efficiencies despite dislocation densities of up to $10^{10}$ cm$^{-2}$ [13]. The simulations indicate, however, that the smaller thresholds come at the expense of a higher slope reduction. This is as carrier loss taking place in a more concentrated region seems to introduce a sharper drop in the local gain, which requires higher gain in dislocation-free regions, i.e. more carriers and thus a higher injection current to compensate for this.

With respect to practical applications, it should finally be noted that long-wavelength devices at 1.3 μm or 1.5 μm will be preferable for silicon photonics or data center singlemode applications. Since QD lasers with their lower modal gain require longer cavities, which limits the photonic chip size as well as direct modulation speeds, there might still be certain applications where QW devices could hold an advantage over their QD-based counterpart in the case that reliable, high-performance QW lasers on silicon become available.

VI. CONCLUSION

By using a rate equation travelling-wave model with high spatial resolution, we have theoretically analyzed how individual dislocations placed along the laser cavity affect the performance of monolithic GaAs-based III-V lasers on silicon substrates. Our simulations confirm the experimentally
observed trends of higher thresholds and reduced slope efficiencies of QD lasers on silicon, while also explaining the tendency of high threshold currents observed in monolithic QW lasers on silicon. By showing in detail how diffusion-assisted carrier loss in dislocations and the corresponding reduction in local gain influence the carrier, gain, and photon distributions in different types of active regions, our approach is capable of unveiling phenomena not observable using constant laser parameters averaged over the entire device. Two findings with particular significance for practical applications are that first, structures with a short minority carrier diffusion length show a much smaller dislocation density dependent threshold increase than QW structures with longer ones, and secondly, that increased gain in dislocation-free regions compensating for gain dips around dislocations may contribute to gain compression effects observed in directly modulated silicon-based QD lasers. In explaining the physical mechanisms still limiting the performance of III-V QW lasers on silicon, we hope to open up new pathways to be explored in order to make both monolithic III-V QD and QW lasers grown on silicon accessible to future silicon photonics applications.

REFERENCES


